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Client Code: IRDM.128C1 RECORDATION FOR PATENTS	S ONLY
To the Director, U.S. Patent and Trademark Office: Please r	ecord the attached original documents or copy thereof.
1. Name of conveying party:	Name and address of receiving party:
Iridigm Display Corporation	Name: IDC, LLC
Additional name(s) of conveying party(ies)	Internal Address:
attached?	Street Address: 2415 Third Street
() Yes (X) No	City: San Francisco State: CA ZIP: 94107
	Additional name(s) of receiving party(ies) attached?
 3. Nature of conveyance: (X) Assignment () Security Agreement () Merger () Change of Name 	() Yes (X) No
() Other: Execution Date: October 1, 2004	4. US Patent Application:
Execution Date: October 1, 2004	(X) Patent Application No.: 11/396,245
	Filing Date: March 31, 2006
	Additional numbers attached?
	() Yes (X) No
Party to whom correspondence concerning document should be mailed:	 Total number of applications and patents involved: 1
Customer No. 59,747	
Address: Knobbe, Martens, Olson & Bear, LLP 2040 Main Street, 14 th Floor Irvine, CA 92614 Return Fax: (949) 760-9502 Attorney's Docket No.: IRDM.128C1	
7. Total fee (37 CFR 1.21(h)): \$40	8. Deposit account number: 11-1410
(X) Authorized to be charged to deposit account	Please charge this account for any additional fees which may be required, or credit any overpayment to this account.
is a true copy of the original document <u>Mallarv K. de Merlier</u> Name of Person Signing 51,609 Registration No. <u>Total number of pages including cover</u> Documents transmitted via Facsimile to be recorded with re-	g information is true and correct, and any attached copy
Director, U.S. Patent P.O. Bo	and Trademark Office ox 1450
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PATENT ASSIGNMENT

This PATENT ASSIGNMENT (the "Assignment") dated October 1, 2004 (the "Effective Date") is made by IRIDIGM DISPLAY CORPORATION, a Delaware corporation (the "Assignor") to IDC, LLC, a Delaware limited liability company (the "Assignee").

INTRODUCTION

The Assignor has certain ownership interests in the patents and patent applications listed on Exhibit A.

The parties desire to have a recordable instrument assigning from the Assignor to the Assignee all of the Assignor's ownership interests in and to the patents and patent applications listed on Exhibit A and any and all provisionals, continuations, divisions, continuation-in-parts, reissues, reexaminations, extensions, substitutions, and foreign counterparts thereof, including all United States and foreign patents issuing therefrom, and with respect to all European Patent Convention patents and patent applications, including corresponding rights in national patents in any member state in which the European Patent, when granted, is nationalized (all of the foregoing, collectively, the "**Patents**").

AGREEMENT

NOW, THEREFORE, in accordance with the obligations to assign the Patents and other good and valuable consideration, the receipt and sufficiency of which are hereby acknowledged, the Assignor agrees to the foregoing and as follows:

1. The Assignor does and will sell, assign and transfer to Assignee, the Assignor's entire ownership interest in and to each of the Patents, including, without limitation, the rights to file foreign applications directly in the name of the Assignee and to claim for any such foreign applications any priority rights to which such applications are entitled under international conventions, treaties, or otherwise.

2. The Assignor agrees that, upon request and without further compensation, and at the expense of the Assignor, the Assignor and the Assignor's legal representatives and assigns will do all lawful acts, including the execution of papers and the giving of testimony, that may be necessary or desirable for obtaining, sustaining, reissuing, or enforcing each of the Patents in the United States and throughout the world, and for perfecting, recording, or maintaining the title of Assignee, and Assignee's successors and assigns, in and to each of the Patents in the United States and throughout the world. In the event that Assignee is unable for any reason to secure an Assignor's signature to any document that may be necessary or desirable for obtaining, sustaining, reissuing, or enforcing each of the Patents in the United States and throughout the world, or for perfecting, recording, or maintaining the title of Assignee, and Assignee's successors and assigns, in and to each of the Patents in the United States and throughout the world, the Assignor hereby irrevocably designates and appoints Assignee and Assignee's duly authorized officers and agents as the Assignor's agents and attorneys-in-fact to act for and on the

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Assignor's behalf and instead of the Assignor to execute such document, all with the same legal force and effect as if executed by the Assignor.

3. The Assignor authorizes and requests the Assistant Commissioner for Patents of the United States and the various counterparts thereof throughout the world to issue and/or grant any Letters Patent granted for each of the Patents to Assignee, its successors and assigns, as the assignee of the entire interest in such Patents.

RIDIG	M DISPLAY CORPORATION	
Ву:		
Name:	JOHN BATEL	
Titl e : _	CHIEF OPERATING OFFICER	

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EXHIBIT A

August 30, 2004

JAPAN 05/01/1995 UNITED STATES 05/05/1994 WIPO 05/01/1995 UNITED STATES 04/23/1986 UNITED STATES 04/23/1986 UNITED STATES 01/12/1989 UNITED STATES 01/12/1989 UNITED STATES 03/05/1990 UNITED STATES 03/05/1990 UNITED STATES 01/1993 UNITED STATES 05/01/1993 UNITED STATES 02/25/2002 INTERFEROMETRIC MODULATION JAPAN 11/06/1996 09-518276 UNITED STATES 01/27/1999 UNITED STATES 01/27/1999 UNITED STATES 01/27/1999 UNITED STATES 11/16/1995 INTERFEROMETRIC MODULATION OF UNITED STATES 12/19/1996 UNITED STATES 12/19/1996 UNITED STATES 11/21/2001 UNITED STATES 11/21/2001 UNITED STATES 02/19/2002 UNITED STATES 01/05/2004 VISIBLE SPECTRUM MODULATOR ARI	Serial #	Issucd	Patent #	Status
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	UNITED STATES	08/01/2001	09/921,196	6,589,625	07/08/2003	ISSUED
	CONTROLLING MIC	RO-ELECTROME	<u>CHANICAL CAV</u>	<u>ITIES</u>		
	UNITED STATES	02/12/20 02	10/076,224	6,710,908	03/23/2004	ISSUED
	A METHOD FOR FAE (MEMS) DEVICE	BRICATING <u>A ST</u>	<u>RUCTURE FOR N</u>	MICROELECTR	<u>OMECHANICAL</u>	<u>SYSTEMS</u>
	UNITED STATES WIPO	02/12/2002 04/29/2002	10/074,562 US02/13442			ALLOWED PENDING
	MICROELECTRICMECHANICAL SYSTEMS DEVICE AND METHOD FOR FABRICATING SAME					
·	UNITED STATES WIPO	02/27/2002 04/29/2002	10/084,893 US02/13462	6,574,033	06/03/2003	ISSUED PENDING
	A DEVICE HAVING A LIGHT-ABSORBING MASK AND A METHOD FOR FABRICATING SAME					
· .	UNITED STATES WIPO	07/02/2002 06/27/2003	10/190,400 US03/20433	6,741,377	05/25/2004	ISSUED PENDING
	CONTROLLING ELE MICROELECTROME	CTROMECHANI	<u>CAL BEHAVIOR</u> TEMS DEVICE	OF STRUCTUR	<u>RES WITHIN A</u>	
I	UNITED STATES WIPO TAIWAN	09/18/2003 09/20/2002 09/18/2003	10/251,196 US03/30016 92125860			PENDING PENDING PENDING
	A METHOD FOR MANUFACTURING AN ARRAY OF INTERFEROMETRIC MODULATORS					
	UNITED STATES	04/15/2003	10/414,594			PENDING
	THIN FILM PRECUR	SOR STACK FOR	<u>R MEMS MANUF</u>	ACTURING		
	UNITED STATES	06/24/2003	10/606,001			PENDING
-	SEPARABLE MODU	ILATOR				
	UNITED STATES	08/19/2003	10/644,312			PENDING
	<u>AREA ARRAY MOI</u>	ULATION AND	LEAD REDUCTIO	<u>ON IN INTERFE</u>	ROMETRIC MOI	DULATOR ARRAYS
	UNITED STATES	12/09/2003				PENDING
	METHOD TO CHANGE TEMPORAL RESPONSE OF IMODS					
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UNITED STATES	03/03/2004	PENDING		
IMOD WITH INTEGRATED SHUNT RESISTOR NETWORK				
UNITED STATES	02/03/2004	PENDING		
INTEGRAL MODULATOR ILLUMINATION				
UNITED STATES	03/04/2004	PENDING		
MEMS DEVICES WITH	I UNRELEASED THIN FILM COMPONENTS			
UNITED STATES	11/03/2003	PENDING		

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RECORDED: 05/17/2010

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